



Docket No.: 4006-150

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Chun-Lien SU

Application No. 10/054,962

Filed: January 25, 2002

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Group Art Unit: 1765

Examiner: Chen, Kin Chan

For: METHOD FOR CONTROLLING AND MONITORING A CHEMICAL  
MECHANICAL POLISHING PROCESS

RECEIVED  
OCT 31 2003  
TC 1700

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby petition the Commissioner of Patents and Trademarks to extend the time for response to the Official Action dated June 24, 2003 for one month from September 24, 2003 to October 24, 2003.

A credit card authorization form to cover the cost of the extension is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No.: 07-1337.

Respectfully submitted,  
LOWE HAUPTMAN GILMAN & BERNER, LLP

Benjamin J. Hauptman  
Registration No. 29,310

10/28/2003 TLUU11 00000056 10054962  
01 FC:1251 110.00 OP

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**DATE: October 24, 2003**  
BJH:jk